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GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

November 26, 2025

IGI Report Number **LG752520926**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **HEXAGONAL STEP CUT**

Measurements **9.51 X 4.62 X 3.18 MM**

GRADING RESULTS

Carat Weight **1.15 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **VERY GOOD**

Fluorescence **NONE**

Inscription(s) **IGI LG752520926**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG752520926
Report verification at igi.org

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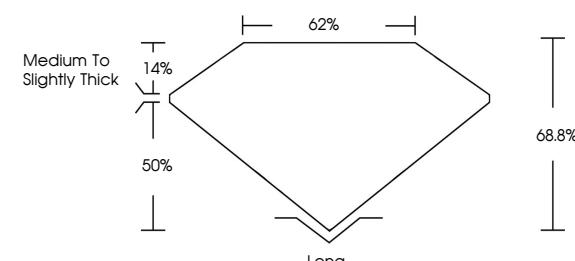
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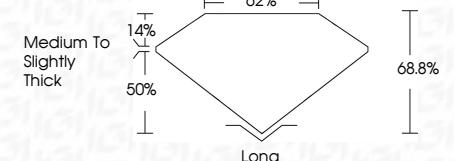
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PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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November 26, 2025
IGI Report No. LG752520926
HEXAGONAL STEP CUT
9.51 X 4.62 X 3.18 MM
1.15 CARAT
E
VS 2
68.8%
62%
Medium To Slightly Thick
Long
EXCELLENT
VERY GOOD
NONE
IGI LG752520926
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Type IIa